

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:
Youhei SAKAI
Serial No: 10/599,544
Filed: May 23, 2007
Confirmation No.: 1542
For: Silicon Casting Apparatus and Method of
Producing Silicon Ingot

Art Unit: 1793
Examiner: Diana J. Liao

RESPONSE TO RESTRICTION REQUIREMENT

Mail Stop **AMENDMENT**
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

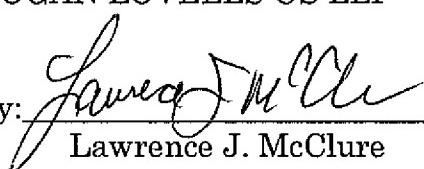
Dear Sir:

In response to the Restriction Requirement dated August 9, 2010, Applicant elects for prosecution Group I, claims 1-14 drawn to a silicon casting apparatus. Applicant also requests that since the nonelected dependent claims 15 to 17 depend from elected independent claim 1, the nonelected dependent claims 15 to 17 be rejoined if the elected claim 1 is found allowable.

If there are any fees due in connection with the filing of this response, please charge the fees to our Deposit Account No. 50-1314.

Respectfully submitted,
HOGAN LOVELLS US LLP

Date: September 8, 2010

By: 
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